

REPLACEMENT SHEET

Title of the Invention: Top-Oxide-Early Process and Array Top Oxide Planarization
Inventor's Name: Kim et al.
Docket No./Application No.: 10/710,566

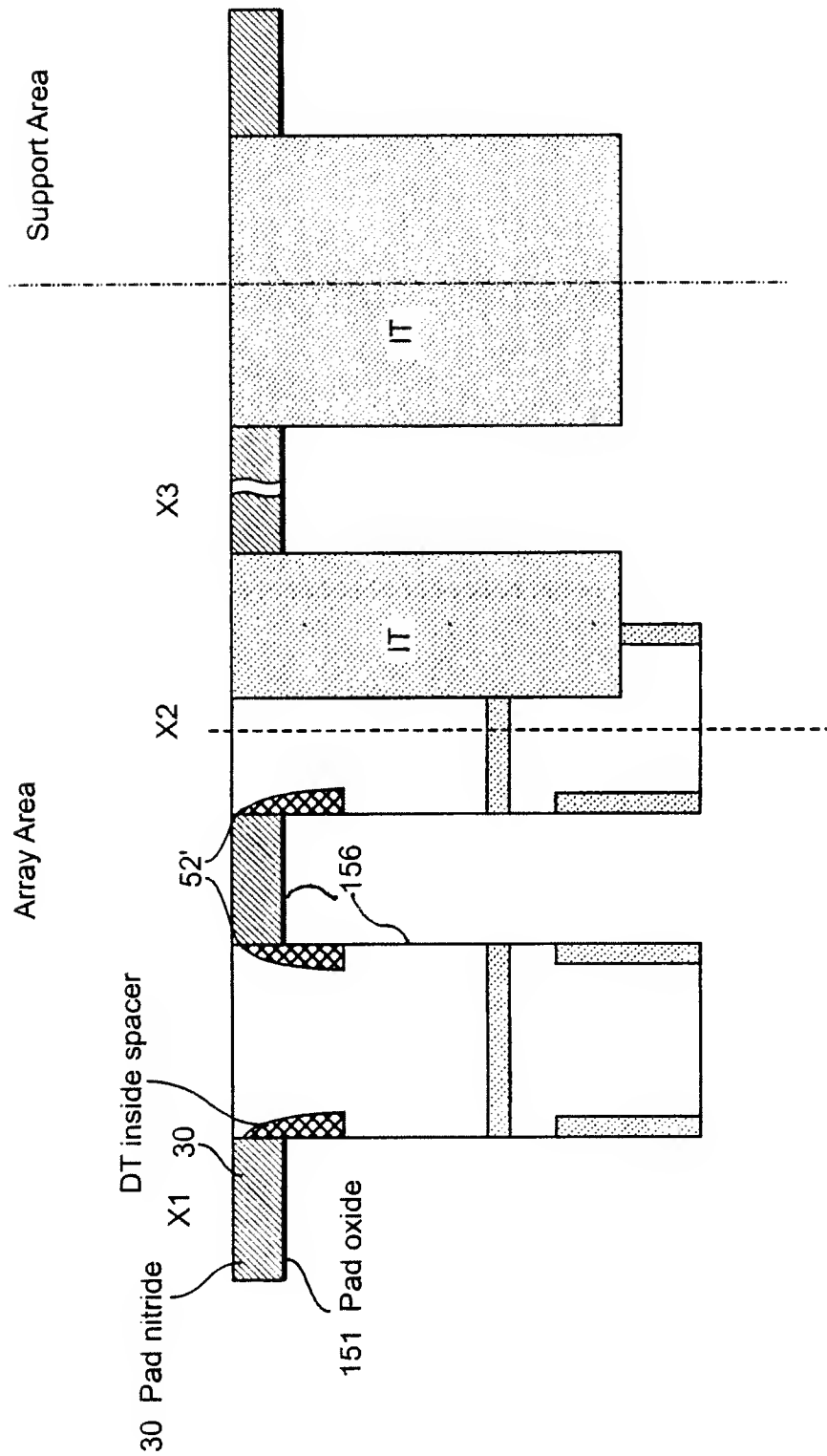


Figure 15A